

# 12

## Bipolar Transistor Level 504

## **12.1 Introduction**

The 504 model provides a detailed description of a vertical integrated circuit and discrete bipolar transistor. It is meant to be used for DC, transient and AC analysis at all current levels, i.e. high and low injection, quasi and hard saturation. This new level 504 version of the Mextram model gives better results for the description of first and higher-order derivatives of the device characteristics than Mextram level 503. This can be especially seen in the output conductance, the cut-off frequency and the low frequency third order distortion. Special attention was paid to the modelling of SiGe transistors. Furthermore we include self-heating in the description.

## 12.2 Order in which terminals are specified

For the TN device:      TN\_n (C, B, E) <parameters>

For the TNS device:    TNS\_n (C, B, E, S) <parameters>

For the TNT device:    TNT\_n (C, B, E, DT) <parameters>

For the TNST device:   TNST\_n (C, B, E, S, DT) <parameters>

For the TP device:     TP\_n (C, B, E) <parameters>

For the TPS device:    TPS\_n (C, B, E, S) <parameters>

For the TPT device:    TPT\_n (C, B, E, DT) <parameters>

For the TPST device:   TPST\_n (C, B, E, S, DT) <parameters>

n                        : occurrence indicator

<parameters>        : list of model parameters

C, B, E, S and DT are collector, base, emitter, substrate and thermal terminals respectively

## 12.3 Survey of modeled effects

- Bias-dependent Early effect
- Low-level non-ideal base currents
- High injection effects
- Ohmic resistance of the epilayer
- Velocity saturation effects on the resistance of the epilayer
- Hard and quasi-saturation (including Kirk effect)
- Weak avalanche (optionally snap-back behaviour)
- Charge storage effects
- Split base-collector and base-emitter depletion capacitance
- Substrate effects and parasitic PNP
- Explicit modelling of inactive regions
- Current crowding and conductivity modulation of the base resistance
- First order approximation of distributed high frequency effects in the intrinsic base (high-frequency current crowding and excess phase-shift)
- Recombination in the base (meant for SiGe transistors)
- Early effect in the case of a graded bandgap (SiGe)
- Temperature scaling
- Self-heating
- Thermal noise, shot noise and  $1/f$  noise

## 12.4 Parameters

The parameters for TN and TP-level-504 are listed in the table below.

Position in list	Parameter name	Units	Description
1	<i>LEVEL</i>	-	Model level, must be set to 504
2	<i>MULT</i>	-	Multiplication factor
3	<i>TREF</i>	°C	Reference temperature
4	<i>DTA</i>	°C	Difference of the device temperature to the ambient temperature ( $T_{DEVICE} = T_{AMBIENT} + DTA$ )
5	<i>EXMOD</i>	-	Flag for extended modeling of the reverse current gain
6	<i>EXPHI</i>	-	Flag for the distributed high frequency effects in transient
7	<i>EXAVL</i>	-	Flag for extended modeling of avalanche currents
8	<i>IS</i>	A	Collector-emitter saturation current
9	<i>IK</i>	A	Collector-emitter high injection knee current
10	<i>VER</i>	V	Reverse Early voltage
11	<i>VEF</i>	V	Forward Early voltage
12	<i>BF</i>	-	Ideal forward current gain
13	<i>IBF</i>	A	Saturation current of the non-ideal forward base current
14	<i>MLF</i>	-	Non-ideality factor of the non-ideal forward base current
15	<i>XIBI</i>	-	Part of ideal base current that belongs to the sidewall
16	<i>BRI</i>	-	Ideal reverse current gain
17	<i>IBR</i>	A	Saturation current of the non-ideal reverse base current
18	<i>VLR</i>	V	Cross-over voltage of the non-ideal reverse base current
19	<i>XEXT</i>	-	Part of $I_{EX}$ , $Q_{EX}$ , $Q_{TEX}$ and $I_{SUB}$ that depends on the base-collector voltage $V_{BC1}$ instead of $V_{B1C1}$
20	<i>WAVL</i>	m	Epilayer thickness used in weak-avalanche model
21	<i>VAVL</i>	V	Voltage determining curvature of avalanche current

Position in list	Parameter name	Units	Description
22	<i>SFH</i>	-	Current spreading factor of avalanche model (When <i>EXAVL</i> =1)
23	<i>RE</i>	$\Omega$	Emitter resistance
24	<i>RBC</i>	$\Omega$	Constant part of the base resistance
25	<i>RBV</i>	$\Omega$	Variable part of the base resistance at zero bias
26	<i>RCC</i>	$\Omega$	Constant part of the collector resistance
27	<i>RCV</i>	$\Omega$	Resistance of the unmodulated epilayer
28	<i>SCRCV</i>	$\Omega$	Space charge resistance of the epilayer
29	<i>IHC</i>	A	Critical current for velocity saturation in the epilayer
30	<i>AXI</i>	-	Smoothness parameter for the onset of quasi-saturation
31	<i>CJE</i>	F	Zero bias emitter-base depletion capacitance
32	<i>VDE</i>	V	Emitter-base diffusion voltage
33	<i>PE</i>	-	Emitter-base grading coefficient
34	<i>XCJE</i>	-	Fraction of the emitter-base depletion capacitance that belongs to the sidewall
35	<i>CBEO</i>	-	Emitter-base overlap capacitance
36	<i>CJC</i>	F	Zero bias collector-base depletion capacitance
37	<i>VDC</i>	V	Collector-base diffusion voltage
38	<i>PC</i>	-	Collector-base grading coefficient
39	<i>XP</i>	-	Constant part of of <i>CJC</i>
40	<i>MC</i>	-	Collector current modulation coefficient
41	<i>XCJC</i>	-	Fraction of the collector-base depletion capacitance under the emitter area
42	<i>CBCO</i>	-	Collector-base overlap capacitance
43	<i>MTAU</i>	-	Non-ideality factor of the emitter stored charge
44	<i>TAUE</i>	s	Minimum transit time of stored emitter charge
45	<i>TAUB</i>	s	Transit time of stored base charge

<b>Position in list</b>	<b>Parameter name</b>	<b>Units</b>	<b>Description</b>
46	<i>TEPI</i>	s	Transit time of stored epilayer charge
47	<i>TAUR</i>	s	Transit time of reverse extrinsic stored base charge
48	<i>DEG</i>	eV	Bandgap difference over the base
49	<i>XREC</i>	-	Pre-factor of the recombination part of $I_{B1}$
50	<i>AQBO</i>	-	Temperature coefficient of the zero bias base charge
51	<i>AE</i>	-	Temperature coefficient of the resistivity of the emitter
52	<i>AB</i>	-	Temperature coefficient of the resistivity of the base
53	<i>AEPI</i>	-	Temperature coefficient of the resistivity of the epilayer
54	<i>AEX</i>	-	Temperature coefficient of the resistivity of the extrinsic base
55	<i>AC</i>	-	Temperature coefficient of the resistivity of the buried layer
56	<i>DVGBF</i>	V	Band-gap voltage difference of forward current gain
57	<i>DVGBR</i>	V	Band-gap voltage difference of reverse current gain
58	<i>VGB</i>	V	Band-gap voltage of the base
59	<i>VGC</i>	V	Band-gap voltage of the collector
60	<i>VGJ</i>	V	Band-gap voltage recombination emitter-base junction
61	<i>DVGTE</i>	V	Band-gap voltage difference of emitter stored charge
62	<i>AF</i>	-	Flickernoise exponent
63	<i>KF</i>	-	Flickernoise coefficient ideal base current
64	<i>KFN</i>	-	Flickernoise coefficient non-ideal base current

The additional parameters for the TNS and TPS-level-504 are listed in the table below.

<b>Position in list</b>	<b>Parameter name</b>	<b>Units</b>	<b>Description</b>
65	<i>ISS</i>	A	Base-substrate saturation current
66	<i>IKS</i>	A	Base-substrate high injection knee current
67	<i>CJS</i>	F	Zero bias collector-substrate depletion capacitance
68	<i>VDS</i>	V	Collector-substrate diffusion voltage
69	<i>PS</i>	-	Collector-substrate grading coefficient
70	<i>VGS</i>	V	Band-gap voltage of the substrate
71	<i>AS</i>	-	For a closed buried layer: $AS=AC$ For an open buried layer: $AS=AEPI$

The additional parameters for the thermal models TNT, TNST, TPT and TPST-level-504 are listed in the table below.

<b>Position in list</b>	<b>Parameter name</b>	<b>Units</b>	<b>Description</b>
72	<i>RTH</i>	°C/W	Thermal resistance
73	<i>CTH</i>	J/°C	Thermal capacitance



**Parameter *MULT***

This parameter may be used to put several transistors in parallel. To scale the geometry of a transistor use of the process-block is preferable over using this feature.

The following parameters are multiplied by *MULT*:

*IS IK IBF IBR IHC ISS IKS CJE CJC CJS CTH CBCO CBEO*

Divided by *MULT* are:

*RE RBC RBV RCC RCV SCRCV RTH*

The flicker-noise coefficients are scaled as:

$$KF \rightarrow KF \cdot MULT^{(1-AF)}$$

$$KFN \rightarrow KFN \cdot MULT^{1 - [2(MLF - 1) + AF(2 - MLF)]}$$

**Default and clipping values**

The default values and clipping values for the TN and TP-level-504 are listed below.

No.	Parameter	Units	Default	Clip low	Clip high
1	<i>LEVEL</i>	-	504	-	-
2	<i>MULT</i>	-	1.00	0.0	-
3	<i>TREF</i>	°C	25.00	-273.15	-
4	<i>DTA</i>	°C	0.00	-	-
5	<i>EXMOD</i>	-	1.00	0.00	1.00
6	<i>EXPHI</i>	-	1.00	0.00	1.00
7	<i>EXAVL</i>	-	0.00	0.00	1.00
8	<i>IS</i>	A	$22.00 \times 10^{-18}$	0.00	-
9	<i>IK</i>	A	0.10	$1.0 \times 10^{-12}$	-
10	<i>VER</i>	V	2.50	0.01	-
11	<i>VEF</i>	V	44.00	0.01	-
12	<i>BF</i>	-	215.00	$1.0 \times 10^{-4}$	-
13	<i>IBF</i>	A	$2.70 \times 10^{-15}$	0.00	-
14	<i>MLF</i>	-	2.00	0.10	-
15	<i>XIBI</i>	-	0.00	0.00	1.00
16	<i>BRI</i>	-	7.00	$1.00 \times 10^{-4}$	-
17	<i>IBR</i>	A	$1.00 \times 10^{-15}$	0.00	-
18	<i>VLR</i>	V	0.20	-	-
19	<i>XEXT</i>	-	0.63	0.00	1.00
20	<i>WAVL</i>	m	$1.10 \times 10^{-6}$	$1.00 \times 10^{-9}$	-
21	<i>VAVL</i>	V	3.00	0.01	-
22	<i>SFH</i>	-	0.30	0.00	-
23	<i>RE</i>	Ω	5.00	$1.00 \times 10^{-6}$	-

No.	Parameter	Units	Default	Clip low	Clip high
24	<i>RBC</i>	$\Omega$	23.00	$1.00 \times 10^{-6}$	-
25	<i>RBV</i>	$\Omega$	18.00	$1.00 \times 10^{-6}$	-
26	<i>RCC</i>	$\Omega$	12.00	$1.00 \times 10^{-6}$	-
27	<i>RCV</i>	$\Omega$	150.00	$1.00 \times 10^{-6}$	-
28	<i>SCRCV</i>	$\Omega$	1250.00	$1.00 \times 10^{-6}$	-
29	<i>IHC</i>	A	$4.00 \times 10^{-3}$	$1.00 \times 10^{-12}$	-
30	<i>AXI</i>	-	0.30	0.02	-
31	<i>CJE</i>	F	$73.00 \times 10^{-15}$	0.00	-
32	<i>VDE</i>	V	0.95	0.05	-
33	<i>PE</i>	-	0.40	0.01	0.99
34	<i>XCJE</i>	-	0.40	0.00	1.00
35	<i>CBEO</i>	-	0.00	0.00	-
36	<i>CJC</i>	F	$78.00 \times 10^{-15}$	0.00	-
37	<i>VDC</i>	V	0.68	0.05	-
38	<i>PC</i>	-	0.5	0.01	0.99
39	<i>XP</i>	-	0.35	0.00	0.99
40	<i>MC</i>	-	0.5	0.00	1.00
41	<i>XCJC</i>	-	$32.00 \times 10^{-3}$	0.00	1.00
42	<i>CBCO</i>	-	0.00	0.00	-
43	<i>MTAU</i>	-	1.00	0.10	-
44	<i>TAUE</i>	s	$2.00 \times 10^{-12}$	0.00	-
45	<i>TAUB</i>	s	$4.20 \times 10^{-12}$	0.00	-
46	<i>TEPI</i>	s	$41.00 \times 10^{-12}$	0.00	-
47	<i>TAUR</i>	s	$520.00 \times 10^{-12}$	0.00	-
48	<i>DEG</i>	eV	0.00	-	-

No.	Parameter	Units	Default	Clip low	Clip high
49	<i>XREC</i>	-	0.00	0.00	-
50	<i>AQBO</i>	-	0.30	-	-
51	<i>AE</i>	-	0.00	-	-
52	<i>AB</i>	-	1.00	-	-
53	<i>AEPI</i>	-	2.50	-	-
54	<i>AEX</i>	-	0.62	-	-
55	<i>AC</i>	-	2.00	-	-
56	<i>DVGBF</i>	V	$50.00 \times 10^{-3}$	-	-
57	<i>DVGBR</i>	V	$45.00 \times 10^{-3}$	-	-
58	<i>VGB</i>	V	1.17	0.10	-
59	<i>VGC</i>	V	1.18	0.10	-
60	<i>VGJ</i>	V	1.15	0.10	-
61	<i>DVGTE</i>	V	0.05	-	-
62	<i>AF</i>	-	2.00	0.01	-
63	<i>KF</i>	-	$20.00 \times 10^{-12}$	0.00	-
64	<i>KFN</i>	-	$20.00 \times 10^{-12}$	0.00	-

The default values and clipping values for the TNS and TPS-level-504 are listed below.

No.	Parameter	Units	Default	Clip low	Clip high
65	<i>ISS</i>	A	$48.00 \times 10^{-18}$	0.00	-
66	<i>IKS</i>	A	$250.00 \times 10^{-6}$	$1.0 \times 10^{-12}$	-
67	<i>CJS</i>	F	$315.00 \times 10^{-15}$	0.00	-
68	<i>VDS</i>	V	0.62	0.05	-
69	<i>PS</i>	-	0.34	0.01	0.99
70	<i>VGS</i>	V	1.20	0.10	-
71	<i>AS</i>	-	1.58	-	-

The default values and clipping values for the TNT, TNST, TPT and TPST-level-504 are listed below.

No.	Parameter	Units	Default	Clip low	Clip high
72	<i>RTH</i>	°C/W	300.00	0.00	-
73	<i>CTH</i>	J/°C	$3.00 \times 10^{-9}$	0.00	-

## 12.5 Pstar specific items

### 12.5.1 The ON/OFF condition

The solution of a circuit involves a process of successive calculations. The calculations are started from a set of 'initial guesses' for the electrical quantities of the non-linear elements. A simplified DCAPPROX mechanism for devices using ON/OFF keywords is mentioned in [46]. By default the devices start in the default state.

TN-level 504			
	Default	ON	OFF
$V_{BC1}$	-1.0	0.0	-1.0
$V_{B1C1}$	-1.0	0.0	-1.0
$V_{B2C1}$	-1.0	0.0	-1.0
$V_{B2C2}$	-1.0	0.0	-1.0
$V_{B1E1}$	0.65	0.75	-0.3
$V_{B2E1}$	0.65	0.75	-0.3
$V_{B1B2}$	$1.0 \times 10^{-6}$	$1.0 \times 10^{-6}$	0.0

TNT-level 504			
	Default	ON	OFF
DT	0.0	0.0	0.0

TNS-level 504			
	Default	ON	OFF
$V_{BC1}$	-1.0	0.0	-1.0
$V_{B1C1}$	-1.0	0.0	-1.0
$V_{B2C1}$	-1.0	0.0	-1.0
$V_{B2C2}$	-1.0	0.0	-1.0
$V_{B1E1}$	0.65	0.75	-0.3
$V_{B2E1}$	0.65	0.75	-0.3
$V_{B1B2}$	$1.0 \times 10^{-6}$	$1.0 \times 10^{-6}$	0.0
$V_{SC1}$	-5.0	-5.0	-5.0

TNST- level 504			
	Default	ON	OFF
DT	0.0	0.0	0.0

For the TP, TPS, TPT and TPST-level 504 the numbers are inverse.

### 12.5.2 Numerical Adaptation

To implement the model in a circuit simulator, care must be taken of the numerical stability of the simulation program. A small non-physical conductance,  $G_{min}$ , is connected between the nodes  $B1C1$  and  $B2E1$ . The value of the conductance is  $10^{-13}$  [ $1/\Omega$ ].

### 12.5.3 DC operating point output

The operating point information is a list of quantities that describe the internal state of the transistor. When a circuit simulator is able to provide these, it might help the designer understand the behaviour of the transistor and the circuit. The full list of operating point information consist of three parts. First we have all the branch biases, the currents and the charges. Then we have, as usual, the elements that can be used if a full small-signal equivalent circuit is needed. These are all the derivatives of the charges and currents. At last, and possibly the most informative, we have given approximations to the small-signal model which together form a hybrid- $\pi$  model with similar behaviours as the full Mextram model. In addition the cut-off frequency is included. Note that  $G_{min}$  is not included in the expressions of the operating point information.

Since we have 5 internal nodes we need 5 voltage differences to describe the bias at each internal node, given the external biases. We take those that are the most informative for the internal state of the transistor:

The small signal equivalent circuit contains the following conductances. In the terminology we use the notation  $A_x$ ,  $A_y$ , and  $A_z$  to denote derivatives of the quantity  $A$  to some voltage difference. We use  $x$  for base-emitter biases,  $y$  is for derivatives w.r.t.  $V_{B2C2}$  and  $z$  is used for all other base-collector biases. The subindex  $\pi$  is used for base-emitter base currents,  $\mu$  is used for base-collector base currents,  $rbv$  for derivatives of  $I_{B1B2}$  and  $rcv$  for derivatives of  $I_{C1C2}$ . The small signal equivalent circuit is shown in figure 33. The current sources are defined as:

$$\begin{aligned}
 dI_n &= g_x \cdot dV_{B2E1} + g_y \cdot dV_{B2C2} + g_z \cdot dV_{B2C1} \\
 dI_{C1C2} &= g_{rcv_y} \cdot dV_{B2C2} + g_{rcv_z} \cdot dV_{B2C1} \\
 dI_{BE} &= j\omega \cdot (Cbe_y \cdot dV_{B2C2} + Cbe_z \cdot dV_{B2C1}) \\
 dI_{BC} &= g_{\mu x} \cdot dV_{B2E1} + g_{\mu z} \cdot dV_{B2C1} + j\omega \cdot (Cbc_x \cdot dV_{B2E1} + Cbc_z \cdot dV_{B2C1}) \\
 dI_{B1B2} &= g_{rbv_x} \cdot dV_{B2E1} + g_{rbv_y} \cdot dV_{B2C2} + g_{rbv_z} \cdot dV_{B2C1} + j\omega \cdot C_{B1B2_x} \cdot dV_{B2E1} \\
 dSI_{BE} &= j\omega \cdot SC_{TE} \cdot dV_{B2E1}
 \end{aligned}$$

For the TNS device:

$$dI_{SUB} = g_{PNP} \cdot dV_{B1C1} + Xg_{PNP} \cdot dV_{BC1}$$

Quantity	Equation	Description
LEVEL	504	Model level
VB2E1	$V_{B2E1}$	Internal base-emitter bias
VB2C2	$V_{B2C2}$	Internal base-collector bias
VB2C1	$V_{B2C1}$	Internal base-collector bias including epilayer
VB1C1	$V_{B1C1}$	External base-collector bias without contact resistances
VE1E	$V_{E1E}$	Bias over emitter resistance
IN	$I_N$	Main current
IC1C2	$I_{C1C2}$	Epilayer current
IB1B2	$I_{B1B2}$	Pinched-base current
IB1	$I_{B1}$	Ideal forward base current
SIB1	$I_{B1}^S$	Ideal side-wall base current
IB2	$I_{B2}$	Non-ideal forward base current
IB3	$I_{B3}$	Non-ideal reverse base current
I AVL	$I_{avl}$	Avalanche current
I EX	$I_{EX}$	Extrinsic reverse base current
XI EX	$XI_{EX}$	Extrinsic reverse base current

For the TNS device:

ISUB	$I_{sub}$	Substrate current
XISUB	$XI_{sub}$	Substrate current
ISF	$I_{sf}$	Substrate failure current

IRE	$I_{RE}$	Current through emitter resistance
IRBC	$I_{RBC}$	Current through constant base resistance



Quantity	Equation	Description
IRCC	$I_{RCC}$	Current through constant collector resistance
GX	$g_x$	Forward transconductance $\partial I_N / \partial V_{B2E1}$
QE	$Q_E$	Emitter charge or emitter neutral charge
QTE	$Q_{tE}$	Base-emitter depletion charge
SQTE	$Q_{tE}^S$	Sidewall base-emitter depletion charge
QBE	$Q_{BE}$	Base-emitter diffusion charge
QBC	$Q_{BC}$	Base-collector diffusion charge
QTC	$Q_{tC}$	Base-collector depletion charge
QEPI	$Q_{epi}$	Epilayer diffusion charge
QB1B2	$Q_{B1B2}$	AC current crowding charge
QTEX	$Q_{tex}$	Extrinsic base-collector depletion charge
XQTEX	$XQ_{tex}$	Extrinsic base-collector depletion charge
QEX	$Q_{ex}$	Extrinsic base-collector diffusion charge
XQEX	$XQ_{ex}$	Extrinsic base-collector diffusion charge
For the TNS device:		
QTS	$Q_{tS}$	Collector-substrate depletion charge
GY	$g_y$	Reverse transconductance $\partial I_N / \partial V_{B2C2}$
GZ	$g_z$	Reverse transconductance $\partial I_N / \partial V_{B2C1}$
SGPI	$g_\pi^S$	Conductance sidewall b-e junction: $\partial I_{B1}^S / \partial V_{B1E1}$
GPIX	$g_{\pi X}$	Conductance floor b-e junction: $\partial I_{B1} / \partial V_{B2E1} + \partial I_{B2} / \partial V_{B2E1}$
GPIY	$g_{\pi Y}$	Early effect on recombination base current: $\partial I_{B1} / \partial V_{B2C2}$

Quantity	Equation	Description
GPIZ	$g_{\pi Z}$	Early effect on recombination base current: $\partial I_{B1}/\partial V_{B2C1}$
GMUX	$g_{\mu X}$	Early effect on avalanche current limiting: $-\partial I_{AVL}/\partial V_{B2E1}$
GMUY	$g_{\mu Y}$	Conductance of avalanche current: $-\partial I_{AVL}/\partial V_{B2C2}$
GMUZ	$g_{\mu Z}$	Conductance of avalanche current: $-\partial I_{AVL}/\partial V_{B2C1}$
GMUEX	$g_{\mu EX}$	Conductance extrinsic b-c junction: $\partial(I_{EX} + I_{B3})/\partial V_{B1C1}$
XGMUEX	$Xg_{\mu EX}$	Conductance extrinsic b-c junction: $\partial X I_{EX}/\partial V_{BC1}$
GRCVY	$grcv_y$	Conductance of the epilayer current: $\partial I_{C1C2}/\partial V_{B2C2}$
GRCVZ	$grcv_z$	Conductance of the epilayer current: $\partial I_{C1C2}/\partial V_{B2C1}$
RBV	$rbv$	Variable part of the base resistance $1/(\partial I_{B1B2}/\partial V_{B1B2})$
GRBVX	$grbv_X$	Early-effect on base resistance: $\partial I_{B1B2}/\partial V_{B2E1}$
GRBVY	$grbv_Y$	Early-effect on base resistance: $\partial I_{B1B2}/\partial V_{B2C2}$
GRBVZ	$grbv_Z$	Early-effect on base resistance: $\partial I_{B1B2}/\partial V_{B2C1}$
RE	$RE_T$	Emitter resistance
RBC	$RBC_T$	Constant base resistance
RCC	$RCC_T$	Constant collector resistance

For the TNS device:

GS	$g_S$	Conductance parasitic PNP transistor: $\partial I_{SUB}/\partial V_{B1C1}$
XGS	$Xg_S$	Conductance parasitic PNP transistor: $\partial X I_{SUB}/\partial V_{BC1}$
GSUB	$g_{SF}$	Conductance substrate failure current: $\partial I_{SF}/\partial V_{SC1}$

SCBE  $Cbe^S$  Capacitance sidewall b-e junction:  $\partial Q_{TE}^S/\partial V_{B1E1}$

CBEX  $Cbe_X$  Capacitance floor b-e junction:  
 $\partial Q_{TE}/\partial V_{B2E1} + \partial Q_{BE}/\partial V_{B2E1} + \partial Q_E/\partial V_{B2E1}$

CBEY	$Cbe_Y$	Early effect on b-e diffusion charge: $\partial Q_{BE}/\partial V_{B2C2}$
CBEZ	$Cbe_Z$	Early effect on b-e diffusion charge: $\partial Q_{BE}/\partial V_{B2C1}$
CBCX	$Cbc_X$	Early effect on b-c diffusion charge: $\partial Q_{BC}/\partial V_{B2E1}$
CBCY	$Cbc_Y$	Capacitance floor b-c junction: $\partial Q_{TC}/\partial V_{B2C2} + \partial Q_{BC}/\partial V_{B2C2} + \partial Q_{EPI}/\partial V_{B2C2}$
CBCZ	$Cbc_Z$	Capacitance floor b-c junction: $\partial Q_{TC}/\partial V_{B2C1} + \partial Q_{BC}/\partial V_{B2C1} + \partial Q_{EPI}/\partial V_{B2C1}$
CBCEX	$Cbc_{EX}$	Capacitance extrinsic b-c junction: $\partial Q_{TEX}/\partial V_{B1C1} + \partial Q_{EX}/\partial V_{B1C1}$
XCBCEX	$XCbc_{EX}$	Capacitance extrinsic b-c junction: $\partial XQ_{TEX}/\partial V_{BC1} + \partial XQ_{EX}/\partial V_{BC1}$
CB1B2	$C_{B1B2}$	Capacitance AC current crowding: $\partial Q_{B1B2}/\partial V_{B1B2}$
CB1B2X	$C_{B1B2X}$	Capacitance AC current crowding (only used in transient analysis): $\approx \partial Q_{B1B2}/\partial V_{B2E1}$
CB1B2Y	$C_{B1B2Y}$	Capacitance AC current crowding (only used in transient analysis): $\approx \partial Q_{B1B2}/\partial V_{B2C2}$
CB1B2Z	$C_{B1B2Z}$	Capacitance AC current crowding (only used in transient analysis): $\approx \partial Q_{B1B2}/\partial V_{B2C1}$

For the TNS device:

CTS	$C_{TS}$	Capacitance s-c junction: $\partial Q_{TS}/\partial V_{SC1}$
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**Remark:** The operating-point output will not be influenced by the value of  $G_{min}$ .

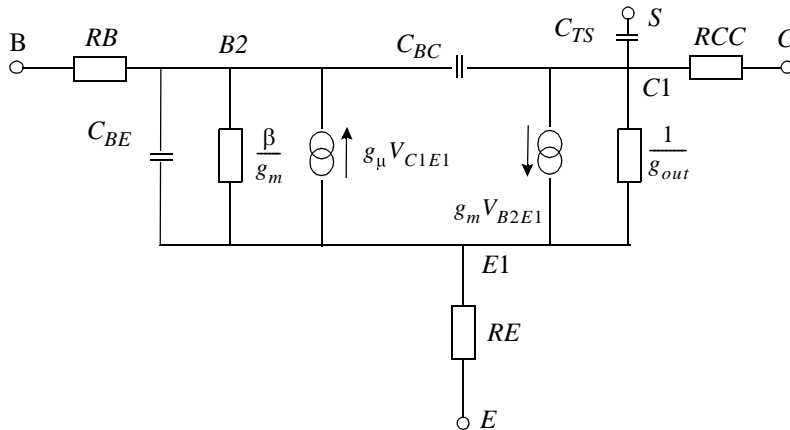


Figure 30: Small-signal equivalent circuit describing the approximate behaviour of the Mextram model. The actual forward Early voltage can be found as  $V_{eaf} = I_C / g_{out} - V_{CE}$  which can be different from the parameter value  $V_{EF}$  especially when  $dE_g \neq 0$ .

The full small-signal circuit is in practice not very useful, since it is difficult to do hand-calculations with it. We therefore include the elements of an approximate small-signal model, shown in figure 30. This model contains the following elements:

Quantity	Equation	Description
GM	$G_M$	Transconductance
BETA	$BETA$	Current amplification
GOUT	$G_{OUT}$	Output conductance
GMU	$G_\mu$	Feedback transconductance
RE	$RE$	Emitter resistance
RB	$RB$	Base resistance
RCC	$RCC$	Constant collector resistance
CBE	$C_{BE}$	Base-emitter capacitance
CBC	$C_{BC}$	Base-collector capacitance

For the TNS device:		
CTS	$C_{TS}$	Collector-substrate capacitance

We make a few assumptions by making this approximation. It is meant to work in forward mode. To keep the model simple, the base-emitter and base-collector capacitance are a sum of various contributions that are in the full model between different nodes. The elements that have not be defined before can be calculated from the small signal parameters of the full model. As help variables we use:

$$\frac{dy}{dx} = \frac{g_X - g_{\mu X}}{grcv_y + g_{\mu Y} - g_Y} \quad (12.1)$$

$$\frac{dy}{dz} = \frac{g_Z - grcv_Z - g_{\mu Z}}{grcv_y + g_{\mu Y} - g_Y} \quad (12.2)$$

$$g_{\pi} = g_{\pi}^S + g_{\pi X} + g_{\mu X} + g_{\pi Z} + g_{\mu Z} + (g_{\pi Y} + g_{\mu Y}) \cdot \left[ \frac{dy}{dx} + \frac{dy}{dz} \right] \quad (12.3)$$

$$g_m = \frac{grcv_y \cdot (g_x - g_{\mu X} + g_z - g_{\mu Z}) - (grcv_z) \cdot (g_Y - g_{\mu Y})}{grcv_y + g_{\mu Y} - g_Y} \quad (12.4)$$

$$\beta = g_m / g_{\pi} \quad (12.5)$$

$$g_{out} = \frac{(g_Y - g_{\mu Y}) \cdot grcv_z - (g_Z - g_{\mu Z}) \cdot grcv_Y}{grcv_y + g_{\mu Y} - g_Y} \quad (12.6)$$

$$g_{\mu} = g_{\pi Z} + g_{\mu Z} + (g_{\pi Y} + g_{\mu Y}) \cdot \frac{dy}{dz} + g_{\mu EX} + Xg_{\mu EX} \quad (12.7)$$

$$RB = RBC_T + rbv \quad (12.8)$$

$$C_{BE} = C_{BE,x} + C_{BE}^S + C_{BC,x} + (C_{BE,y} + C_{BC,y}) \cdot \frac{dy}{dx} + C_{BEO} \quad (12.9)$$

$$C_{BC} = (C_{BE,y} + C_{BC,y}) \cdot \frac{dy}{dz} + C_{BE,z} + C_{BCex} + XC_{BCex} + C_{BCO} \quad (12.10)$$

$$\gamma_X = (g_{\pi X} + g_{\mu X} - grbv_X) \cdot rbv \quad (12.11)$$

$$\gamma_Y = (g_{\pi Y} + g_{\mu Y} - grbv_Y) \cdot rbv \quad (12.12)$$

$$\gamma_Z = (g_{\pi Z} + g_{\mu Z} - grbv_Z) \cdot rbv \quad (12.13)$$

$$g_{BFX} = g_{\pi X} + g_{\pi}^S \cdot (1 + \gamma_X) \quad (12.14)$$

$$g_{BFY} = g_{\pi Y} + g_{\pi}^S \cdot \gamma_Y \quad (12.15)$$

$$g_{BFZ} = g_{\pi Z} + g_{\pi}^S \cdot \gamma_Z \quad (12.16)$$

$$\alpha = \frac{1 + \left[grcv_Y \cdot \frac{dy}{dx}\right] \cdot RCC_T + \left[g_X + g_{BFX} + (g_Y + g_{BFY}) \cdot \frac{dy}{dx}\right] \cdot RE_T}{1 - \left[grcv_Z + grcv_Y \cdot \frac{dy}{dz}\right] \cdot RCC_T - \left[g_Z + g_{BFZ} + (g_Y + g_{BFY}) \cdot \frac{dy}{dz}\right] \cdot RE_T} \quad (12.17)$$

$$r_X = \left[grcv_Y \cdot \frac{dy}{dx} + \alpha \cdot \left(grcv_Z + grcv_Y \cdot \frac{dy}{dz}\right)\right]^{-1} \quad (12.18)$$

$$r_Z = \alpha \cdot r_X \quad (12.19)$$

$$r_Y = \frac{1 - grcv_Z \cdot r_Z}{grcv_Y} \quad (12.20)$$

$$r_{B1B2} = \gamma_X \cdot r_X + \gamma_Y \cdot r_Y + \gamma_Z \cdot r_Z \quad (12.21)$$

$$r_{EX} = r_Z + r_{B1B2} \quad (12.22)$$

$$Xr_{EX} = r_{EX} + RBC_T \cdot [(g_{BFX} + g_{\mu X}) \cdot r_X + (g_{BFY} + g_{\mu Y}) \cdot r_Y + (g_{BFZ} + g_{\mu Z}) \cdot r_Z] \quad (12.23)$$

$$\begin{aligned}
 TAU_T = Cbe^S \cdot (r_X + r_{B1B2}) + (Cbe_X + Cbc_X) \cdot r_X + (Cbe_Y + Cbc_Y) \cdot r_Y + \\
 (Cbe_Z + Cbc_Z) \cdot r_Z + Cbc_{EX} \cdot r_{EX} + XCbc_{EX} \cdot Xr_{EX} + \\
 (CBEO + CBCO) \cdot (Xr_{EX} - RCC_T)
 \end{aligned}
 \tag{12.24}$$

Apart from the cut-off frequency we also have some other quantities to describe the internal state of the model and they are presented as OP output.

Quantity	Equation	Description
FT	$f_T$	Good approximation for cut-off frequency: $1/(2\pi \cdot TAU_T)$
IQS	$I_{qs}$	Current at onset of quasi-saturation
XIWEPI	$x_i/W_{epi}$	Thickness of injection layer
VB2C2STAR	$V_{B2C2}^*$	Physical value of internal base-collector bias

For self-heating we have the following quantities, presented as OP output:

Quantity	Equation	Description
PDISS	$P_{diss}$	Dissipation
TK	$T_K$	Actual temperature

## 12.6 Equivalent circuit and equations

A full description of TN/TNS-level-504 for vertical integrated circuit NPN transistor is given below. The equivalent circuits for the TN-level-504 model are shown in figs. 31 and 33 respectively. The equivalent circuits for the TNS-level-504 model are shown in figs. 32 and 33 respectively.

### ✓ Note

The elements in the figure indicate their position and NOT their functional dependence!

### Embedding of PNP transistors

Although NPN transistors are the most used bipolar transistors it is also necessary to be able to describe PNP-transistors. The equations in this chapter are only for NPN transistors. It is however easy to map a PNP-device with its bias conditions onto an NPN model. to do this we need three steps:

The model uses the following internal voltages:

$$V_{B2C1}, V_{B2C2}, V_{B2E1}, V_{B1E1}, V_{B1B2}, V_{B1C1}, V_{BC1}, V_{SC1}$$

For a PNP the sign of these voltages must be changed ( $V \rightarrow -V$ ). The value of  $V_{dT}$  does *not* change sign.

- Calculate the currents, charges and noise densities with the equations for the NPN transistor. Note that the parameters are still like those for an NPN. For instance all currents like  $I_s$  must be taken positive.
- Change the sign of all resulting currents ( $I \rightarrow -I$ ).

$$I_N, I_{B1B2}, I_{C1C2}, I_{avl}, I_{B1}, I_{B1}^S, I_{B2}, I_{B3}, I_{ex}, XI_{ex}, I_{sub}, XI_{sub}, I_{sf}$$

and charges ( $Q \rightarrow -Q$ )

$$Q_E, Q_{TE}, Q_{TC}, Q_{BE}, Q_{BC}, Q_{epi}, Q_{B1B2}, Q_{ex}, XQ_{ex}, Q_{tex}, XQ_{tex}, Q_{ts}, Q_{BEO}, Q_{BCO}$$

The noise current densities do not change sign. The power dissipation term  $P_{diss}$  and the thermal charge  $C_{th} \cdot V_{dT}$  do not change sign. The following derivatives do need an extra sign:



$$\frac{\partial P_{diss}}{\partial V_{B2E1}}, \text{ etc.}$$

all other derivatives  $\frac{\partial I}{\partial V}$  and  $\frac{\partial Q}{\partial V}$  do not need an extra sign.

Furthermore, note that the constants  $A_n$  and  $B_n$  for the avalanche model are different for NPN's and for PNP's.

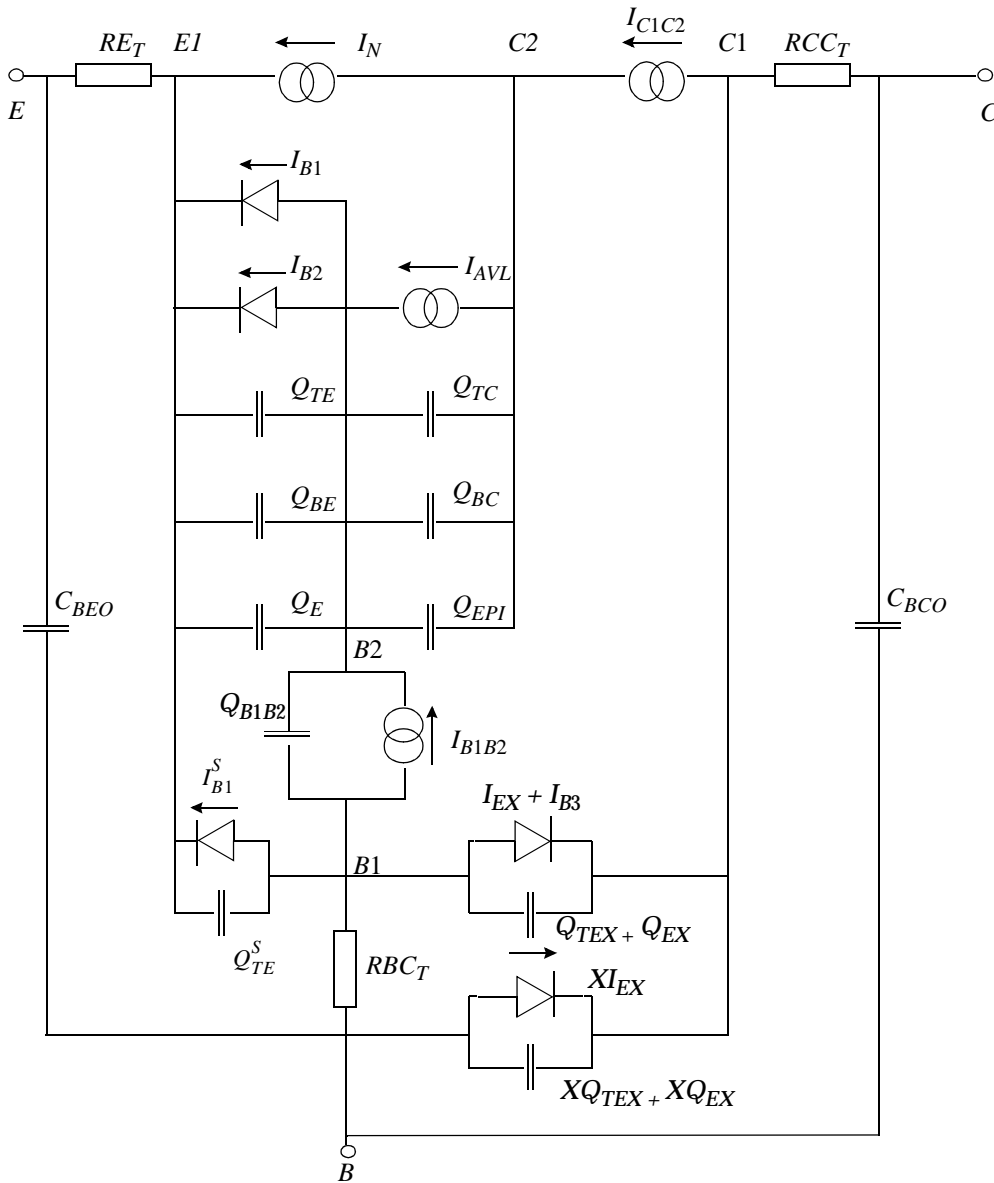


Figure 31: Equivalent circuit for vertical NPN transistor without substrate and self-heating

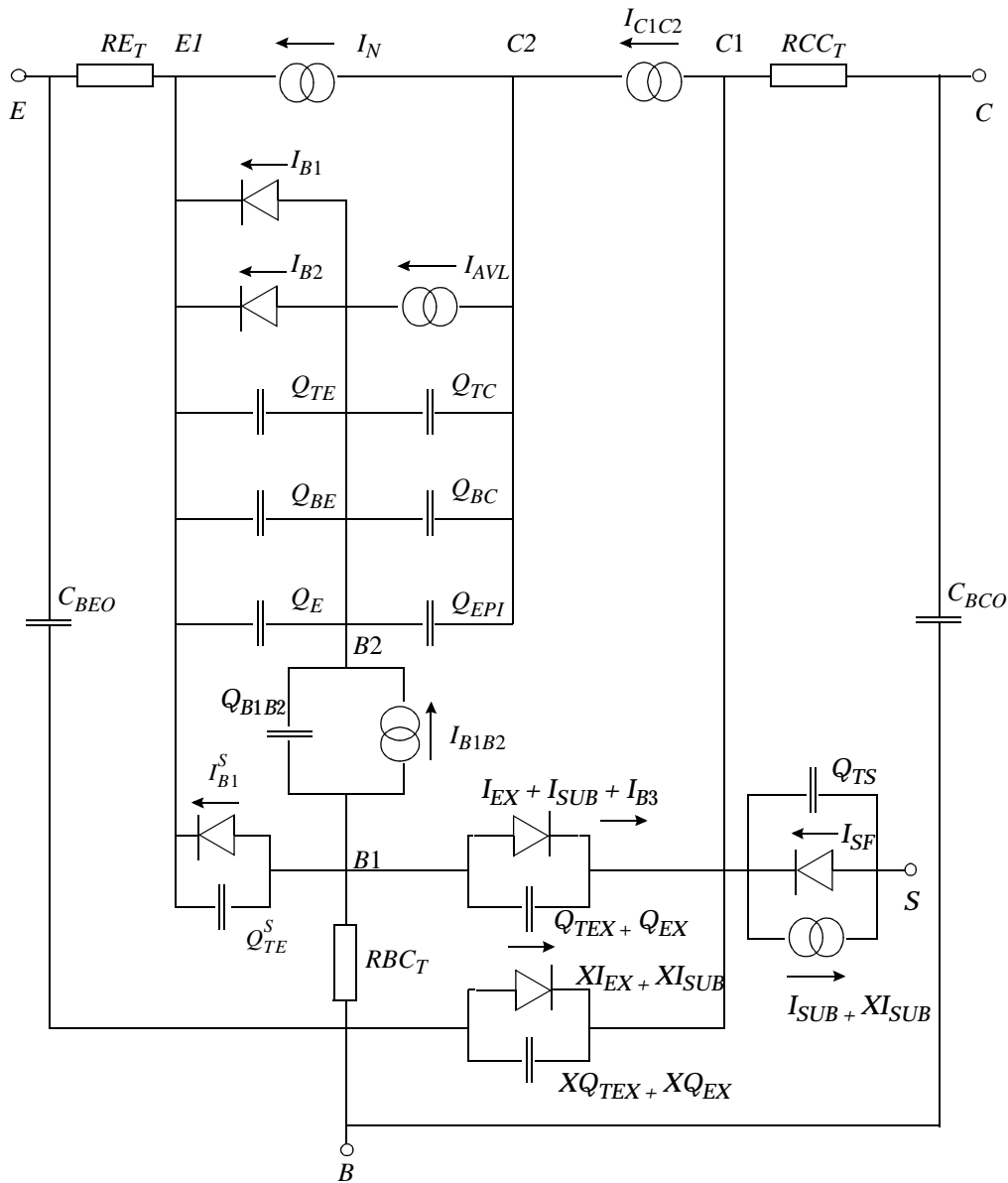


Figure 32: Equivalent circuit for vertical NPN transistor with substrate but without self-heating

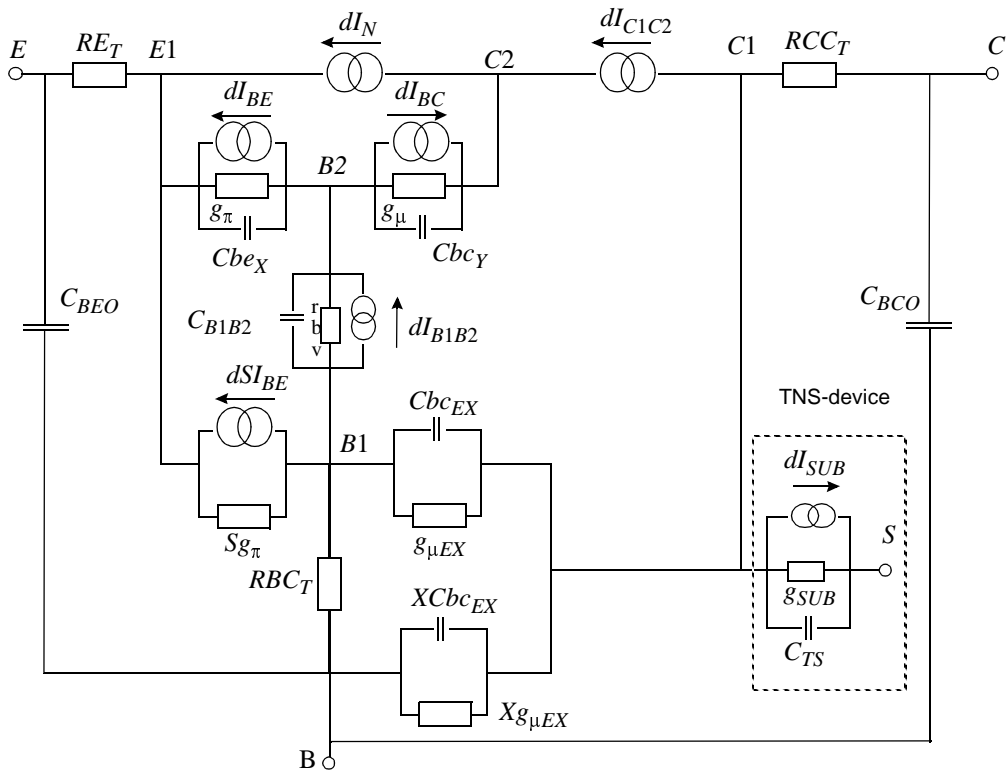


Figure 33: Small signal equivalent for vertical TN/TNS NPN transistor

**Model constants**

$$k = 1.3806226 \cdot 10^{-23} \text{JK}^{-1}$$

$$q = 1.6021918 \cdot 10^{-19} \text{C}$$

$$\left(\frac{k}{q}\right) = 0.86171 \cdot 10^{-4} \text{V/K}$$

$$G_{MIN} = 1.0 \cdot 10^{-13} \text{A/V}$$

$$V_{d,low} = 0.05 \text{ V}$$

$$a_{je} = 3.0$$

$$a_{jc} = 2.0$$

$$a_{js} = 2.0$$

Constants *A* and *B* for impact ionization depend on transistor type:

*for NPN:*

$$A_n = 7.03 \cdot 10^7 \text{m}^{-1}$$

$$B_n = 1.23 \cdot 10^8 \text{V} \cdot \text{m}^{-1}$$

*for PNP:*

$$A_n = 1.58 \cdot 10^8 \text{m}^{-1}$$

$$B_n = 2.04 \cdot 10^8 \text{V} \cdot \text{m}^{-1}$$

The default reference temperature *TREF* for parameter determination is 25 °C.

### Temperature effects

The actual simulation temperature is denoted by  $TEMP$  (in °C). The temperature at which the parameters are determined is  $TREF$  (in °C).

- Conversions to Kelvin

### ✓ Note

Note the addition of the voltage  $V_{dT}$  of the thermal node (See “Self-heating” on page 334.).

$$T_K = TEMP + DTA + 273.15 + V_{dT} \quad (12.25)$$

$$T_{RK} = TREF + 273.15 \quad (12.26)$$

$$t_N = \frac{T_K}{T_{RK}} \quad (12.27)$$

- Thermal Voltage

$$V_T = \left(\frac{k}{q}\right) \cdot T_K \quad (12.28)$$

$$V_{TR} = \left(\frac{k}{q}\right) \cdot T_{RK} \quad (12.29)$$

$$\frac{1}{V_{\Delta T}} = \frac{1}{V_T} - \frac{1}{V_{TR}} \quad (12.30)$$

- Resistances

The various parameters  $A$  describe the mobility of the corresponding regions:

$\mu \sim t_N^{-A}$ . The temperature dependence of the zero-bias charge goes as

$$Q_{B0T}/Q_{B0} = t_N^{AQ_{B0}}.$$

$$RE_T = RE \cdot t_N^{AE} \quad (12.31)$$

$$RBV_T = RBV \cdot t_N^{(AB-AQB0)} \quad (12.32)$$

$$RBC_T = RBC \cdot t_N^{AEX} \quad (12.33)$$

$$RCC_T = RCC \cdot t_N^{AC} \quad (12.34)$$

$$RCV_T = RCV \cdot t_N^{AEPi} \quad (12.35)$$

- Depletion capacitance

The junction diffusion voltages  $VDE$ ,  $VDC$ , and  $VDS$  with respect to temperature are:

$$UDE_T = -3 \cdot V_T \cdot \ln(t_N) + VDE \cdot t_N + (1 - t_N) \cdot VGB \quad (12.36)$$

$$VDE_T = UDE_T + V_T \cdot \ln\{1 + \exp[(V_{d,low} - UDE_T)/V_T]\} \quad (12.37)$$

$$CJE_T = CJE \cdot \left(\frac{VDE}{VDE_T}\right)^{PE} \quad (12.38)$$

where  $VDE$  is the junction diffusion voltage and  $PE$  is the grading coefficient;

$$UDC_T = -3 \cdot V_T \cdot \ln(t_N) + VDC \cdot t_N + (1 - t_N) \cdot VGC \quad (12.39)$$

$$VDC_T = UDC_T + V_T \cdot \ln\{1 + \exp[(V_{d,low} - UDC_T)/V_T]\} \quad (12.40)$$

where  $VDC$  is the junction diffusion voltage.

The collector depletion capacitance is divided in a variable and constant part. The constant part is temperature independent.

$$CJC_T = CJC \cdot \left[ (1 - XP) \cdot \left( \frac{VDC}{VDC_T} \right)^{PC} + XP \right] \quad (12.41)$$

$$XP_T = XP \cdot \left[ (1 - XP) \cdot \left( \frac{VDC}{VDC_T} \right)^{PC} + XP \right]^{-1} \quad (12.42)$$

Where  $PC$  is the grading coefficient.

For the TNS device:

$$UDS_T = -3 \cdot V_T \cdot \ln(t_N) + VDS \cdot t_N + (1 - t_N) \cdot VGS \quad (12.43)$$

$$VDS_T = UDS_T + V_T \cdot \ln \{ 1 + \exp[(V_{d,low} - UDS_T)/V_T] \} \quad (12.44)$$

$$CJS_T = CJS \cdot \left( \frac{VDS}{VDS_T} \right)^{PS} \quad (12.45)$$

Where  $VDS$  is the junction diffusion voltage and  $PS$  is the grading coefficient.

- Current gain

$$BF_T = BF \cdot t_N^{(AE - AB - AQB0)} \cdot \exp[-DVGBF/V_{\Delta T}] \quad (12.46)$$

$$BRI_T = BRI \cdot \exp[-DVGBR/V_{\Delta T}] \quad (12.47)$$

- Currents and Voltages

$$IS_T = IS \cdot t_N^{(4 - AB - AQB0)} \cdot \exp[-VGB/V_{\Delta T}] \quad (12.48)$$

$$IK_T = IK \cdot t_N^{(1 - AB)} \quad (12.49)$$

$$IBF_T = IBF \cdot t_N^{(6 - 2MLF)} \cdot \exp[-VGJ/(MLF \cdot V_{\Delta T})] \quad (12.50)$$



$$IBR_T = IBR \cdot t_N^2 \cdot \exp[-VGC/(2 \cdot V_{\Delta T})] \quad (12.51)$$

$$VEF_T = VEF \cdot t_N^{AQB0} \left[ (1 - XP) \cdot \left( \frac{VDC}{VDC_T} \right)^{PC} + XP \right]^{-1} \quad (12.52)$$

$$VER_T = VER \cdot t_N^{AQB0} \left( \frac{VDE}{VDE_T} \right)^{-PE} \quad (12.53)$$

For the TNS device:

The temperature dependence of  $ISS$  and  $IKS$  is given by  $AS$  and  $VGS$ .

$AS$  equals  $AC$  for a closed buried layer (BN) and  $AS$  equals  $AEPI$  for an open buried layer.

$$ISS_T = ISS \cdot t_N^{(4-AS)} \cdot \exp[-VGS/V_{\Delta T}] \quad (12.54)$$

$$IKS_T = IKS \cdot t_N^{(1-AS)} \cdot \frac{IS_T}{IS} \cdot \frac{ISS}{ISS_T} \quad (12.55)$$

When either  $IS = 0$  or  $ISS_T = 0$  then  $IKS_T = IKS \cdot t_N^{(1-AS)}$

- Transit times

$$TAUE_T = TAUE \cdot t_N^{(AB-2)} \cdot \exp[-DVGTE/V_{\Delta T}] \quad (12.56)$$

$$TAUB_T = TAUB \cdot t_N^{(AQB0+AB-1)} \quad (12.57)$$

$$TEPI_T = TEPI \cdot t_N^{(AEPI-1)} \quad (12.58)$$

$$TAUR_T = TAUR \cdot \frac{TAUB_T + TEPI_T}{TAUB + TEPI} \quad (12.59)$$

- Avalanche constant

Note that this temperature rule is independent of  $T_{REF}$  since we take  $B_n$  as a material constant.

$$B_{nT} = B_n [1 + 7.2 \cdot 10^{-4} (T_K - 300) - 1.6 \cdot 10^{-6} (T_K - 300)^2] \quad (12.60)$$

- Heterojunction features

$$DEG_T = DEG \cdot t_N^{AQB0} \quad (12.61)$$

### Description of currents

- Ideal forward current and reverse current.

$$I_F = IS_T \cdot \exp\left(\frac{V_{B2E1}}{V_T}\right) \quad (12.62)$$

$$I_R = IS_T \cdot \exp\left(\frac{V_{B2C2}^*}{V_T}\right) \quad (12.63)$$

The value of  $V_{B2C2}^*$  is not always the same as the node voltage  $V_{B2C2}$ . The expression for  $\exp(V_{B2C2}^*/V_T)$  is given in Eqs. 12.114 and 12.116.

- The main current  $I_N$

The Moll-Ross or integral charge-control relation is used to take high injection in the base into account. To avoid dividing by zero at punch-through in Eq. 12.67 the depletion charge term  $q_0$  is modified.

### ✓ Note

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For SiGe transistors  $q_0^I$  might differ from  $q_0^Q$ , defined in Eq. 12.95, See “Heterojunction features” on page 330.

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$$q_0^I = 1 + \frac{V_{TE}}{V_{ER_T}} + \frac{V_{TC}}{V_{EF_T}} \quad (12.64)$$

$$q_1^I = \frac{q_0^I + \sqrt{(q_0^I)^2 + 0.01}}{2} \quad (12.65)$$

$$q_B^I = q_1^I \left( 1 + \frac{1}{2}n_0 + \frac{1}{2}n_B \right) \quad (12.66)$$

$$I_N = \frac{I_F - I_R}{q_B^I} \quad (12.67)$$

✓ **Note**

The expressions for  $V_{TE}$ ,  $V_{TC}$ ,  $n_0$  and  $n_B$  are given by Eqs. 12.122, 12.138, 12.153 and 12.156 respectively.

- Forward base currents.

The total ideal base current is separated into a bulk and sidewall component. The bulk component depends on voltage  $V_{B2E1}$  and the sidewall component on voltage  $V_{B1E1}$ . The separation is given by parameter  $XIBI$ .

✓ **Note**

$I_{B1}$  becomes more complicated when  $XREC \neq 0$ . See “Heterojunction features” on page 330.

Bulk component:

$$I_{B1} = (1 - XIBI) \cdot \frac{IS_T}{BF_T} \cdot \left\{ \exp\left(\frac{V_{B2E1}}{V_T}\right) - 1 \right\} \quad (12.68)$$

Sidewall component:

$$I_{B1}^S = XIBI \cdot \frac{IS_T}{BF_T} \cdot \left\{ \exp\left(\frac{V_{B1E1}}{V_T}\right) - 1 \right\} \quad (12.69)$$

The non-ideal base current is given by:

$$I_{B2} = IBF_T \cdot \left\{ \exp\left(\frac{V_{B2E1}}{MLF \cdot V_T}\right) - 1 \right\} + G_{MIN} \cdot V_{B2E1} \quad (12.70)$$

- Reverse base currents.

In TN/TNS-level 504, the non-ideal reverse current is:

$$I_{B3} = IBR_T \cdot \left\{ \frac{\exp\left(\frac{V_{B1C1}}{V_T}\right) - 1}{\exp\left(\frac{V_{B1C1}}{2 \cdot V_T}\right) + \exp\left(\frac{V_{LR_T}}{2 \cdot V_T}\right)} \right\} + G_{MIN} \cdot V_{B1C1} \quad (12.71)$$

For the TNS device:

The substrate current (holes injected from base to substrate or reversely, the main current of the parasitic PNP), including high injection is given by:

$$I_{SUB} = \frac{2 \cdot ISS_T \cdot \left\{ \exp\left(\frac{V_{B1C1}}{V_T}\right) - 1 \right\}}{1 + \sqrt{1 + 4 \cdot \frac{IS_T}{IKS_T} \cdot \left\{ \exp\left(\frac{V_{B1C1}}{V_T}\right) \right\}}} \quad (12.72)$$

The current with substrate bias in forward is only included as a signal to the designer

$$I_{SF} = ISS_T \cdot \left\{ \exp\left(\frac{V_{SC1}}{V_T}\right) - 1 \right\} \quad (12.73)$$

The extrinsic base current (electrons injected from collector to extrinsic base, similar to  $I_{B1}$ ) is given by:

$$g_1 = \frac{4 \cdot IS_T \cdot \exp\left(\frac{V_{B1C1}}{V_T}\right)}{IK_T} \quad (12.74)$$

$$n_{BEX} = \frac{g_1}{1 + \sqrt{1 + g_1}} \quad (12.75)$$

$$I_{EX} = \frac{1}{\beta R I_T} \cdot \left\{ \frac{1}{2} \cdot I_{K_T} \cdot n_{BEX} - I_{S_T} \right\} \quad (12.76)$$

- Weak avalanche current

In reverse mode  $I_{C1C2} \leq 0$  or hard saturation  $V_{B2C1} \geq V_{DC_T}$  the avalanche current is zero.

$$I_{AVL} = 0 \quad (12.77)$$

In forward mode we have the following gradient of the electric field for zero bias:

$$dEdx_0 = \frac{2V_{AVL}}{W_{AVL}^2} \quad (12.78)$$

The depletion layer thickness becomes:

$$X_D = \sqrt{\frac{2}{dEdx_0}} \cdot \sqrt{\frac{V_{DC_T} - V_{B2C1}}{1 - I_{CAP}/I_{HC}}} \quad (12.79)$$

The current  $I_{CAP}$  will be given in Eq. 12.135.

The generation of avalanche current increases at high current levels. This is only taken into account when flag  $EXAVL = 1$ .

When  $EXAVL = 0$ , then the effective thickness of the epilayer is:

$$W_{eff} = W_{AVL} \quad (12.80)$$

When  $EXAVL = 1$ , then:

$$W_{eff} = W_{AVL} \cdot \left( 1 - \frac{X_i}{2 \cdot W_{EPI}} \right)^2 \quad (12.81)$$

For either value of  $EXAVL$  the thickness over which the electric field is important is:

$$W_D = \frac{x_D \cdot W_{eff}}{\sqrt{x_D^2 + W_{eff}^2}} \quad (12.82)$$

The average electric field and the field at the base-collector junction are:

$$E_{AV} = \frac{VDC_T - V_{B2C1}}{W_D} \quad (12.83)$$

$$E_0 = E_{AV} + \frac{1}{2} \cdot W_D \cdot dEdx_0 \cdot \left(1 - \frac{I_{CAP}}{IHC}\right) \quad (12.84)$$

When  $EXAVL = 0$ , then the maximum of the electric field is:

$$E_M = E_0 \quad (12.85)$$

When  $EXAVL = 1$ , then

$$SH_W = 1 + 2 \cdot SFH \cdot \left(1 + \frac{2X_i}{W_{EPI}}\right) \quad (12.86)$$

$$E_{fi} = \frac{1 + SFH}{1 + 2SFH} \quad (12.87)$$

$$E_W = E_{AV} - \frac{1}{2} \cdot W_D \cdot dEdx_0 \cdot \left(E_{fi} - \frac{I_{C1C2}}{IHC \cdot SH_W}\right) \quad (12.88)$$

$$E_M = \frac{1}{2} \cdot (E_W + E_0 + \sqrt{(E_W - E_0)^2 + 0.1 \cdot E_{AV}^2 \cdot I_{CAP}/IHC}) \quad (12.89)$$

The injection thickness  $X_i/W_{EPI}$  is given in Eq. 12.111.

For either value of  $EXAVL$  the intersection point  $\lambda_D$  and the generation factor  $G_{EM}$  are:

$$\lambda_D = \frac{E_M \cdot W_D}{2 \cdot (E_M - E_{AV})} \quad (12.90)$$

$$G_{EM} = \frac{A_n}{B_{nT}} \cdot E_M \cdot \lambda_D \cdot \left\{ \exp\left(\frac{-B_{nT}}{E_M}\right) - \exp\left[\frac{-B_{nT}}{E_M} \cdot \left(1 + \frac{W_{eff}}{\lambda_D}\right)\right] \right\} \quad (12.91)$$

When  $E_M \approx E_{AV}$  the expression for  $\lambda_D$  will diverge. Hence for  $(1 - E_{AV}/E_M) < 10^{-7}$  we need to take the appropriate analytical limit and get:

$$G_{EM} = A_n \cdot W_{eff} \cdot \exp\left(\frac{-B_{nT}}{E_M}\right) \quad (12.92)$$

The generation factor may not exceed 1 and may not exceed

$$G_{MAX} = \frac{V_T}{I_{C1C2} \cdot (RBC_T + RB2)} + \frac{q_B^I}{BF_T} + \frac{RE_T}{RBC_T + RB2} \quad (12.93)$$

The variable base resistance  $RB2$  is given in Eq. 12.98. The base charge term  $q_B^I$  is given by Eq. 12.66. The current  $I_{C1C2}$  is given by Eq. 12.104. The avalanche current then is:

$$I_{AVL} = I_{C1C2} \cdot \frac{G_{EM} \cdot G_{MAX}}{G_{EM} \cdot (1 + G_{MAX}) + G_{MAX}} \quad (12.94)$$

- Series resistances:

$$\text{emitter: } RE_T = \text{constant}$$

$$\text{base: } RBC_T = \text{constant}$$

$$\text{collector: } RCC_T = \text{constant}$$

- Variable base resistance

The variable part of the base resistance is modulated by the base charges and takes into account the base current crowding:

$$q_0^Q = 1 + \frac{V_{TE}}{V_{ER_T}} + \frac{V_{TC}}{V_{EF_T}} \quad (12.95)$$

$$q_1^Q = \frac{q_0^Q + \sqrt{(q_0^Q)^2 + 0.01}}{2} \quad (12.96)$$

$$q_B^Q = q_1^Q \left( 1 + \frac{1}{2}n_0 + \frac{1}{2}n_B \right) \quad (12.97)$$

$$RB2 = \frac{3 \cdot RBV_T}{q_B^Q} \quad (12.98)$$

$$I_{B1B2} = \frac{2 \cdot V_T}{RB2} \cdot \left\{ \exp\left(\frac{V_{B1B2}}{V_T}\right) - 1 \right\} + \frac{V_{B1B2}}{RB2} \quad (12.99)$$

### ✓ Note

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Note the correspondance and differences between RB2 and  $I_N$  from Eq. 12.67

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- Variable collector resistance.

This model of the epilayer resistance takes into account:

- The decrease in resistance due to carriers injected from the base if only the internal base-collector junction is forward biased (quasi-saturation) and if both the internal and external base-collector junction are forward biased (hard saturation and reverse mode of operation).
- Ohmic current flow at low current densities.
- Space charge limited current flow at high current densities (Kirk effect; only in forward mode).

The current through the epilayer is given by:

$$K_0 = \sqrt{1 + 4 \cdot \exp[(V_{B2C2} - VDC_T)/V_T]} \quad (12.100)$$

$$K_W = \sqrt{1 + 4 \cdot \exp[(V_{B2C1} - VDC_T)/V_T]} \quad (12.101)$$



$$p_W = \frac{2 \cdot \exp[(V_{B2C1} - VDC_T)/V_T]}{1 + K_W} \quad (12.102)$$

For numerical reasons: when  $p_W < e^{-40}$  then  $p_W \rightarrow 0$

$$E_C = V_T \cdot \left[ K_0 - K_W - \ln\left(\frac{K_0 + 1}{K_W + 1}\right) \right] \quad (12.103)$$

$$I_{C1C2} = \frac{E_C + V_{C1C2}}{RCV_T} \quad (12.104)$$

In reverse mode the node voltage difference  $V_{B2C2}$  is the quantity that we use in further calculations. In forward mode the relation between the voltage difference  $V_{B2C2}$  and the current  $I_{C1C2}$  is not smooth enough. We will instead calculate  $V_{B2C2}^*$  that is to be used in subsequent calculations. It has smoother properties than  $V_{B2C2}$  itself. In forward mode the node voltage  $V_{C2}$  is only used for Eqs. 12.100 and 12.104. For the rest of the quantities in the epilayer model a distinction must be made between forward and reverse mode.

Forward mode ( $I_{C1C2} > 0$ ) The voltage and current at which quasi-saturation or Kirk effect start are:

$$V_{qs}^{th} = VDC_T + 2 \cdot V_T \cdot \ln\left(\frac{I_{C1C2} \cdot RCV_T}{2 \cdot V_T} + 1\right) - V_{B2C1} \quad (12.105)$$

$$V_{qs} = \frac{1}{2} \left\{ V_{qs}^{th} + \sqrt{(V_{qs}^{th})^2 + 4 \cdot (0.1VDC_T)^2} \right\} \quad (12.106)$$

$$I_{qs} = \frac{V_{qs}}{SCRCV} \cdot \frac{V_{qs} + IHC \cdot SCRCV}{V_{qs} + IHC \cdot RCV_T} \quad (12.107)$$

$$\alpha = \frac{1 + AXI \cdot \ln\{1 + \exp[(I_{C1C2}/I_{qs} - 1)/AXI]\}}{1 + AXI \cdot \ln\{1 + \exp[-1/AXI]\}} \quad (12.108)$$

We need to solve:

$$\alpha \cdot I_{qs} = \frac{V_{qs}}{SCRCV \cdot y_i^2} \cdot \frac{V_{qs} + SCRCV \cdot IHC \cdot y_i}{V_{qs} + RCV_T \cdot IHC}$$

which leads to

$$v = \frac{V_{qs}}{IHC \cdot SCRCV} \quad (12.109)$$

$$y_i = \frac{1 + \sqrt{1 + 4 \cdot \alpha \cdot v \cdot (1 + v)}}{2 \cdot \alpha \cdot (1 + v)} \quad (12.110)$$

The injection thickness is given by:

$$\frac{x_i}{W_{epi}} = 1 - \frac{y_i}{1 + p_W \cdot y_i} \quad (12.111)$$

The hole density  $p_0^*$  at the base-collector junction is

$$g = \frac{I_{C1C2} \cdot RCV_T}{2 \cdot V_T} \cdot \frac{x_i}{W_{epi}} \quad (12.112)$$

$$p_0^* = \frac{g-1}{2} + \sqrt{\left(\frac{g-1}{2}\right)^2 + 2g + p_W \cdot (p_W + g + 1)} \quad (12.113)$$

For numerical reasons: when  $p_0^* < e^{-40}$  then  $p_0^* \rightarrow 0$

$$e^{V_{B2C2}/V_T} = p_0^* \cdot (p_0^* + 1) \exp(VDC_T/V_T) \quad (12.114)$$

Reverse mode ( $I_{C1C2} \leq 0$ ) The hole density at the base-collector junction is:

$$p_0^* = \frac{2 \exp\{(V_{B2C2} - VDC_T)/V_T\}}{1 + K_0} \quad (12.115)$$

$$\exp(V_{B2C2}^*/V_T) = \exp(V_{B2C2}/V_T) \quad (12.116)$$

The injection thickness is:

$$\frac{x_i}{W_{epi}} = \frac{E_c}{E_c + V_{B2C2} - V_{B2C1}} \quad (12.117)$$

Numerical problems might arise for  $I_{C1C2} \approx 0$ . When  $|V_{C1C2}| < 10^{-5}V_T$  or  $|E_c| < e^{-40}V_T(K_0 + K_W)$  approximate

$$p_{av} = \frac{p_0^* + p_W}{2} \quad (12.118)$$

$$\frac{x_i}{W_{epi}} = \frac{p_{av}}{p_{av} + 1} \quad (12.119)$$

### Description of charges

- Emitter depletion charges

The total base-emitter depletion capacitance is separated into a bulk and sidewall component. The bulk component is located between node *E1* and node *B2* and the sidewall component between nodes *B1* and *E1* (see Fig. 32).

The bulk component is:

$$V_{FE} = VDE_T \cdot (1 - a_{jE}^{-1/PE}) \quad (12.120)$$

$$V_{jE} = V_{B2E1} - 0.1VDE_T \cdot \ln\{1 + \exp[(V_{B2E1} - V_{FE})/0.1VDE_T]\} \quad (12.121)$$

$$V_{TE} = \frac{VDE_T}{1 - PE} \cdot [1 - (1 - V_{jE}/VDE_T)^{1-PE}] + a_{jE} \cdot (V_{B2E1} - V_{jE}) \quad (12.122)$$

$$Q_{TE} = (1 - XCJE) \cdot CJE_T \cdot V_{TE} \quad (12.123)$$

The sidewall component is

$$V_{jE}^S = V_{B1E1} - 0.1VDE_T \cdot \ln \{ 1 + \exp[(V_{B1E1} - V_{FE})/0.1VDE_T] \} \quad (12.124)$$

$$Q_{TE}^S = XCJE \cdot CJE_T \cdot \left( \frac{VDE_T}{1 - PE} \cdot [1 - (1 - V_{jE}^S/VDE_T)^{1 - PE}] + a_{jE} \cdot (V_{B1E1} - V_{jE}^S) \right) \quad (12.125)$$

- Intrinsic collector depletion charge

In forward mode ( $I_{C1C2} > 0$ ) then

$$B_1 = \frac{1}{2} SCRCV \cdot (I_{C1C2} - IHC) \quad (12.126)$$

$$B_2 = SCRCV \cdot RCV_T \cdot IHC \cdot I_{C1C2} \quad (12.127)$$

$$V_{xi=0} = B_1 + \sqrt{B_1^2 + B_2} \quad (12.128)$$

In reverse mode ( $I_{C1C2} \leq 0$ ) then

$$V_{xi=0} = V_{C1C2} \quad (12.129)$$

The junction voltage for the capacitance is given by

$$V_{junc} = V_{B2C1} + V_{xi=0} \quad (12.130)$$

$$V_{ch} = \begin{cases} 0.1VDC_T & I_{C1C2} \leq 0 \\ VDC_T \cdot \left( 0.1 + 2 \cdot \frac{I_{C1C2}}{I_{C1C2} + I_{qs}} \right) & I_{C1C2} > 0 \end{cases} \quad (12.131)$$

$$b_{jc} = \frac{a_{jc} - XP_T}{1 - XP_T} \quad (12.132)$$

$$V_{FC} = VDC_T \cdot (1 - b_{jc}^{-1/PC}) \quad (12.133)$$

$$V_{jc} = V_{junc} - V_{ch} \cdot \ln\{1 + \exp[(V_{junc} - V_{FC})/V_{ch}]\} \quad (12.134)$$

$$I_{CAP} = \begin{cases} \frac{IHC \cdot I_{C1C2}}{IHC + I_{C1C2}} & I_{C1C2} > 0 \\ I_{C1C2} & I_{C1C2} \leq 0 \end{cases} \quad (12.135)$$

$$f_I = \left(1 - \frac{I_{CAP}}{IHC}\right)^{MC} \quad (12.136)$$

$$V_{CV} = \frac{VDC_T}{1-PC} \cdot [1 - f_I \cdot (1 - V_{jc}/VDC_T)^{1-PC}] + f_I \cdot b_{jc} \cdot (V_{junc} - V_{jc}) \quad (12.137)$$

$$V_{TC} = (1 - XP_T) \cdot V_{CV} + XP_T \cdot V_{B2C1} \quad (12.138)$$

$$Q_{TC} = XCJC \cdot CJC_T \cdot V_{TC} \quad (12.139)$$

- Extrinsic collector depletion charges  $Q_{TEX}$  and  $XQ_{TEX}$ .

The extrinsic collector depletion charge is partitioned between nodes B1 and C1 and nodes B and C1 respectively, independent of flag *EXMOD*.

$$V_{jC_{EX}} = V_{B1C1} - 0.1VDC_T \cdot \ln\{1 + \exp[(V_{B1C1} - V_{FC})/0.1VDC_T]\} \quad (12.140)$$

$$VTEX_V = \frac{VDC_T}{1-PC} \cdot [1 - (1 - V_{jC_{EX}}/VDC_T)^{1-PC}] + b_{jc} \cdot (V_{B1C1} - V_{jC_{EX}}) \quad (12.141)$$

$$Q_{TEX} = CJC_T \cdot [(1 - XP_T) \cdot VTEX_V + XP_T \cdot V_{B1C1}] \cdot (1 - XCJC) \cdot (1 - XEXT) \quad (12.142)$$

$$XV_{jC_{EX}} = V_{B1C1} - 0.1VDC_T \cdot \ln\{1 + \exp[(V_{B1C1} - V_{FC})/0.1VDC_T]\} \quad (12.143)$$

$$XVTEX_V = \frac{VDC_T}{1-PC} \cdot [1 - (1 - XV_{jC_{EX}}/VDC_T)^{1-PC}] + b_{jC} \cdot (V_{BC1} - XV_{jC_{EX}}) \quad (12.144)$$

$$XQ_{TEX} = CJC_T \cdot [(1 - XP_T) \cdot XVTEX_V + XP_T \cdot V_{BC1}] \cdot (1 - XCJC) \cdot XEXT \quad (12.145)$$

For the TNS device:

Depletion charge  $Q_{TS}$ .

$$V_{FS} = VDS_T \cdot (1 - a_{js}^{-1/PS}) \quad (12.146)$$

$$V_{jS} = V_{SC1} - 0.1VDS_T \cdot \ln\{1 + \exp[(V_{SC1} - V_{FS})/0.1VDS_T]\} \quad (12.147)$$

$$Q_{TS} = CJS_T \cdot \left\{ \frac{VDS_T}{1-PS} \cdot [1 - (1 - V_{jS}/VDS_T)^{1-PS}] + a_{js} \cdot (V_{SC1} - V_{jS}) \right\} \quad (12.148)$$

- Stored emitter charge  $Q_E$

$$Q_{E0} = TAUE_T \cdot IK_T \cdot \left( \frac{IS_T}{IK_T} \right)^{1/MTAU} \quad (12.149)$$

$$Q_E = Q_{E0} \cdot (e^{V_{B2E1}/MTAU \cdot V_T} - 1) \quad (12.150)$$

- Stored base charges

$$Q_{B0} = TAUB_T \cdot IK_T \quad (12.151)$$

$$f_1 = \frac{4 \cdot IS_T}{IK_T} \cdot \exp\left(\frac{V_{B2E1}}{V_T}\right) \quad (12.152)$$

$$n_0 = \frac{f_1}{1 + \sqrt{1 + f_1}} \quad (12.153)$$

$$Q_{BE} = \frac{1}{2} \cdot Q_{B0} \cdot n_0 \cdot q_1^Q \quad (12.154)$$

$$f_2 = \frac{4 \cdot IS_T}{IK_T} \cdot \exp\left(\frac{V_{B2C2}^*}{V_T}\right) \quad (12.155)$$

$$n_B = \frac{f_2}{1 + \sqrt{1 + f_2}} \quad (12.156)$$

$$Q_{BC} = \frac{1}{2} \cdot Q_{B0} \cdot n_B \cdot q_1^Q \quad (12.157)$$

The expression for  $\exp\left(\frac{V_{B2C2}^*}{V_T}\right)$  is given in Eqs. 12.114 and 12.116.

- Stored epilayer charge

$$Q_{EPI0} = \frac{4 \cdot TEPI_T \cdot V_T}{RCV_T} \quad (12.158)$$

$$Q_{EPI} = \frac{1}{2} \cdot Q_{EPI0} \cdot \frac{x_i}{W_{EPI}} \cdot (p_0^* + p_W + 2) \quad (12.159)$$

- Stored extrinsic charges

$$g_2 = 4 \cdot \exp\left(\frac{V_{B1C1} - VDC_T}{V_T}\right) \quad (12.160)$$

$$p_{WEX} = \frac{g_2}{1 + \sqrt{1 + g_2}} \quad (12.161)$$

$$Q_{EX} = \frac{TAUR_T}{TAUB_T + TEPI_T} \cdot \left(\frac{1}{2} \cdot Q_{B0} \cdot n_{Bex} + \frac{1}{2} \cdot Q_{EPI0} \cdot p_{Wex}\right) \quad (12.162)$$

The electron density  $n_{Bex}$  is given in Eq. 12.75.

- Overlap charges

The overlap capacitances  $C_{BEO}$  and  $C_{BCO}$  are constant.

### Extended modeling of the reverse current gain $EXMOD=1$

- Currents

The reverse currents  $I_{EX}$  and  $I_{SUB}$  are redefined

$$I_{EX} \rightarrow (1 - XEXT) \cdot I_{EX} \quad (12.163)$$

For the TNS device:

$$I_{SUB} \rightarrow (1 - XEXT) \cdot I_{SUB} \quad (12.164)$$

The part  $XEXT$  of the reverse currents in the extrinsic transistor are connected to the external base node;

$$Xg_1 = \frac{4 \cdot IS_T \cdot \exp\left(\frac{V_{BC1}}{V_T}\right)}{IK_T} \quad (12.165)$$

$$Xn_{BEX} = \frac{Xg_1}{1 + \sqrt{1 + Xg_1}} \quad (12.166)$$

$$XIM_{EX} = \frac{XEXT}{BRI_T} \cdot \left(\frac{1}{2} \cdot IK_T \cdot Xn_{BEX} - IS_T\right) \quad (12.167)$$

For the TNS device:

$$XIM_{SUB} = XEXT \cdot \frac{2 \cdot ISS_T \cdot \left\{ \exp\left(\frac{V_{BC1}}{V_T}\right) - 1 \right\}}{1 + \sqrt{1 + 4 \cdot \frac{IS_T}{IK_S T} \cdot \left\{ \exp\left(\frac{V_{BC1}}{V_T}\right) \right\}}} \quad (12.168)$$



To improve the convergency behaviour the diode-like currents in the branch B-C1 are limited by a resistance of value  $RCC_T$ :

For the TN device:

$$V_{EX} = V_T \cdot \left\{ 2 - \ln \left( \frac{XEXT \cdot (IS_T / BRI_T) \cdot RCC_T}{V_T} \right) \right\} \quad (12.169)$$

For the TNS device:

$$V_{EX} = V_T \cdot \left\{ 2 - \ln \left( \frac{XEXT \cdot (IS_T / BRI_T + ISS_T) \cdot RCC_T}{V_T} \right) \right\} \quad (12.170)$$

$$VB_{EX} = \frac{1}{2} \cdot [(V_{BC1} - V_{EX}) + \sqrt{(V_{BC1} - V_{EX})^2 + 0.0121}] \quad (12.171)$$

For the TN-device:

$$F_{EX} = \frac{VB_{EX}}{XIM_{EX} \cdot RCC_T + VB_{EX} + XEXT \cdot IS_T \cdot RCC_T / BRI_T} \quad (12.172)$$

For the TNS-device:

$$F_{EX} = \frac{VB_{EX}}{XEXT \cdot (IS_T / BRI_T + ISS_T) \cdot RCC_T + (XIM_{EX} + XIM_{SUB}) \cdot RCC_T + VB_{EX}} \quad (12.173)$$

$$XI_{SUB} = F_{EX} \cdot XIM_{SUB} \quad (12.174)$$

$$XI_{EX} = F_{EX} \cdot XIM_{EX} \quad (12.175)$$

- Charges

The charge  $Q_{EX}$  is redefined:

$$Q_{EX} \rightarrow (1 - XEXT) \cdot Q_{EX} \quad (12.176)$$

$$Xg_2 = 4 \cdot \exp\left\{\left(\frac{V_{BC1} - V_{DC_T}}{V_T}\right)\right\} \quad (12.177)$$

$$Xp_{WEX} = \frac{Xg_2}{1 + \sqrt{1 + Xg_2}} \quad (12.178)$$

$$XQ_{EX} = F_{EX} \cdot XEXT \cdot \frac{TAUR_T}{TAUB_T + TEPI_T} \cdot \left(\frac{1}{2} \cdot Q_{B0} \cdot Xn_{BEX} + \frac{1}{2} \cdot Q_{EPI0} \cdot Xp_{WEX}\right) \quad (12.179)$$

### Distributed high frequency effects in the intrinsic base

Distributed high frequency effects are modeled, in first order approximation, both in lateral direction (current crowding) and in vertical direction (excess phase shift). The distributed effects are an optional part of the Mextram model and can be switched on/off by a flag (on:  $EXPHI = 1$  and off:  $EXPHI = 0$ ). The high frequency current crowding is modeled by;

$$Q_{B1B2} = \frac{1}{5} \cdot V_{B1B2} \cdot \left( \frac{\partial Q_{TE}}{\partial V_{B2E1}} + \frac{1}{2} \cdot Q_{B0} \cdot q_1^Q \cdot \frac{\partial n_0}{\partial V_{B2E1}} + \frac{\partial Q_E}{\partial V_{B2E1}} \right) \quad (12.180)$$

For simplicity reasons only the forward depletion and diffusion charges are taken into account. (Note that the second term is the derivative of  $Q_{BE} = \frac{1}{2} \cdot Q_{B0} \cdot q_1^Q \cdot n_0$ , but with the derivative of  $q_1^Q$  neglected).

In vertical direction (excess phase shift) base-charge-partitioning is used. For simplicity reasons it is only implemented for the forward base charge ( $Q_{BE}$ ) and for high level injection. Now  $Q_{BE}$  (Eq. 12.154) and  $Q_{BC}$  (Eq. 12.157) are redefined according to;

$$Q_{BC} \rightarrow \frac{1}{3} \cdot Q_{BE} + Q_{BC} \quad (12.181)$$

$$Q_{BE} \rightarrow \frac{2}{3} \cdot Q_{BE} \quad (12.182)$$

### Heterojunction features

The most important difference between SiGe and pure Si transistors is the functional difference between hole charges and Gummel number. When the Ge concentration has a non-zero slope  $dE_g \neq 0$  we redefine the  $q_0^I$  describing the Early effect for the currents (the  $q_0^Q$  remains unchanged).

$$q_0^I \rightarrow \frac{\exp\left(\left[\frac{V_{TE}}{V_{EF_T}} + 1\right] \cdot \frac{DEG_T}{V_T}\right) - \exp\left(\frac{-V_{TC}}{V_{EF_T}} \cdot \frac{DEG_T}{V_T}\right)}{\exp\left(\frac{DEG_T}{V_T}\right) - 1} \quad (12.183)$$

Another feature that might be needed for SiGe transistors is recombination in the base. This changes the forward ideal base current (when  $XREC \neq 0$ ).

$$I_{B1} \rightarrow \frac{IS_T}{BF_T} \cdot (1 - XIBI) \cdot \left[ (1 - XREC) \cdot \left\{ \exp\left(\frac{V_{B2E1}}{V_T}\right) - 1 \right\} \right. \\ \left. + XREC \cdot \left( \exp\left(\frac{V_{B2E1}}{V_T}\right) + \exp\left(\frac{V_{B2C2}^*}{V_T}\right) - 2 \right) \cdot \left( 1 + \frac{V_{TC}}{V_{EF_T}} \right) \right] \quad (12.184)$$

The last term also describes Auger recombination in high injection.

## Noise model

For noise analysis noise current sources are added to the small signal equivalent circuit. In these equations  $f$  represents the operation frequency of the transistor and  $\Delta f$  is the bandwidth. When  $\Delta f$  is taken as 1 Hz, a noise density is obtained.

Thermal noise:

- Emitter Resistor

Emitter Resistor Noise

$$\overline{iN_{RE}^2} = \frac{4 \cdot k \cdot T_K}{RE_T} \cdot \Delta f \quad (12.185)$$

- Base Resistor

$$\overline{iN_{RBC}^2} = \frac{4 \cdot k \cdot T_K}{RBC_T} \cdot \Delta f \quad (12.186)$$

For the variable part of the base resistance a different formula is used, taking into account the effect of current crowding on noise behaviour:

$$\overline{iN_{RBV}^2} = \frac{4 \cdot k \cdot T_K}{RB2} \cdot \frac{4 \exp\left(\frac{V_{B1B2}}{V_T}\right) + 5}{3} \cdot \Delta f \quad (12.187)$$

Base Resistor Noise

$$\overline{iN_{RB}^2} = \overline{iN_{RBV}^2} + \overline{iN_{RBC}^2} \quad (12.188)$$

- Collector Resistor

$$\overline{iN_{RCC}^2} = \frac{4 \cdot k \cdot T_K}{RCC_T} \cdot \Delta f \quad (12.189)$$

For the variable part of the collector resistance we take base-widening into account:

$$\overline{iN_{RCV}^2} = \frac{4 \cdot k \cdot T_K}{RCV_T} \cdot \left(1 + \frac{Q_{EPI}}{Q_{EPI0}}\right) \cdot \Delta f \quad (12.190)$$

### Collector Resistor Noise

$$\overline{iN_{RC}^2} = \overline{iN_{RCV}^2} + \overline{iN_{RCC}^2} \quad (12.191)$$

- Collector current

### Collector current shot noise

$$\overline{iN_C^2} = 2 \cdot q \cdot \frac{I_f + I_r}{q_B} \cdot \Delta f \quad (12.192)$$

- Base Current

### Forward base current shot noise and 1/f noise:

$$\overline{iN_B^2} = \left\{ 2q[|I_{B1}| + |I_{B2}|] + \frac{KF}{f}(1 - XIBI) \cdot \left(\frac{|I_{B1}|}{1 - XIBI}\right)^{AF} + \frac{KFN}{f} \cdot |I_{B2}|^{2 \cdot (MLF - 1) + AF \cdot (2 - MLF)} \right\} \cdot \Delta f \quad (12.193)$$

### Emitter-base sidewall current shot noise and 1/f noise:

$$\overline{iN_{BS}^2} = \left\{ 2 \cdot q \cdot |I_{B1}^S| + \frac{KF}{f} \cdot XIBI \cdot \left(\frac{|I_{B1}^S|}{XIBI}\right)^{AF} \right\} \cdot \Delta f \quad (12.194)$$

### Reverse base current shot noise and 1/f noise:

$$\overline{iN_{B3}^2} = \left\{ 2 \cdot q \cdot |I_{B3}| + \frac{KF}{f} \cdot (|I_{B3}|)^{AF} \right\} \cdot \Delta f \quad (12.195)$$

### Base Current Shot Noise

$$\overline{iN_{RB}^2} = \overline{iN_B^2} + \overline{iN_{BS}^2} + \overline{iN_{B3}^2} \quad (12.196)$$

- Extrinsic Current

Extrinsic current shot noise and  $1/f$  noise

When  $EXMOD = 0$  we have:

$$\overline{iN_{IEX}^2} = \left\{ 2 \cdot q \cdot |I_{EX}| + \frac{KF}{f} \cdot (|I_{EX}|)^{AF} \right\} \cdot \Delta f \quad (12.197)$$

If  $EXMOD = 1$  we have:

$$\overline{iN_{IEX}^2} = \left\{ 2 \cdot q \cdot |I_{EX}| + \frac{KF}{f} \cdot (1 - XEXT) \cdot \left( \frac{|I_{EX}|}{1 - XEXT} \right)^{AF} \right\} \cdot \Delta f \quad (12.198)$$

$$\overline{iN_{XIEX}^2} = \left\{ 2 \cdot q \cdot |XI_{EX}| + \frac{KF}{f} \cdot XEXT \cdot \left( \frac{|XI_{EX}|}{XEXT} \right)^{AF} \right\} \cdot \Delta f \quad (12.199)$$

Extrinsic Current Shot Noise

$$\overline{iN_{EX}^2} = \overline{iN_{IEX}^2} + \overline{iN_{XIEX}^2} \quad (12.200)$$

For the TNS-device:

- Substrate current  
(between nodes B1 and S, resp. B and S)

$$\overline{iN_{ISUB}^2} = 2q \cdot |I_{SUB}| \cdot \Delta f \quad (12.201)$$

$$\overline{iN_{XI_{SUB}}^2} = 2q \cdot |XI_{SUB}| \cdot \Delta f \quad (12.202)$$

Substrate current shot noise

$$\overline{iN_{sub}^2} = \overline{iN_{ISUB}^2} + \overline{iN_{XISUB}^2}$$

### Self-heating

For self-heating an extra network is introduced, see figure 34. It contains the self-heating resistance  $RTH$  and capacitance  $CTH$ , both connected between ground and the temperature node  $DT$ . The value of the voltage  $V_{dT}$  at the temperature node gives the increase in local temperature. The dissipation for the TNT/TPT devices is given by:

$$\begin{aligned} P_{diss} = & I_N \cdot (V_{B2E1} - V_{B2C2}^*) + I_{C1C2} \cdot (V_{B2C2}^* - V_{B2C1}) - I_{avl} \cdot V_{B2C2}^* + \\ & V_{EE1}^2 / RE_T + V_{CC1}^2 / RCC_T + V_{BB1}^2 / RBC_T + \\ & I_{B1B2} \cdot V_{B1B2} + (I_{B1} + I_{B2}) \cdot V_{B2E1} + I_{B1}^S \cdot V_{B1E1} + \\ & (I_{EX} + I_{B3}) \cdot V_{B1C1} + XI_{EX} \cdot V_{BC1} + \end{aligned} \quad (12.203)$$

The dissipation for the TNST/TPST devices is given by:

$$\begin{aligned} P_{diss} = & I_N \cdot (V_{B2E1} - V_{B2C2}^*) + I_{C1C2} \cdot (V_{B2C2}^* - V_{B2C1}) - I_{avl} \cdot V_{B2C2}^* + \\ & V_{EE1}^2 / RE_T + V_{CC1}^2 / RCC_T + V_{BB1}^2 / RBC_T + \\ & I_{B1B2} \cdot V_{B1B2} + (I_{B1} + I_{B2}) \cdot V_{B2E1} + I_{B1}^S \cdot V_{B1E1} + \\ & (I_{EX} + I_{B3} + I_{SUB}) \cdot V_{B1C1} + (XI_{EX} + XI_{SUB}) \cdot V_{BC1} \\ & (XI_{SUB} + I_{SUB} - I_{sf}) \cdot V_{C1S} \end{aligned} \quad (12.204)$$



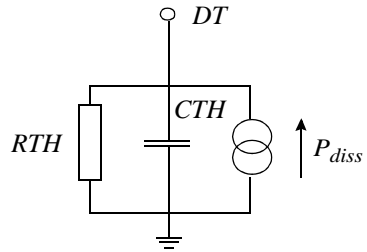


Figure 34: The self-heating network. Note that for increased flexibility the node  $DT$  is available to the user.

